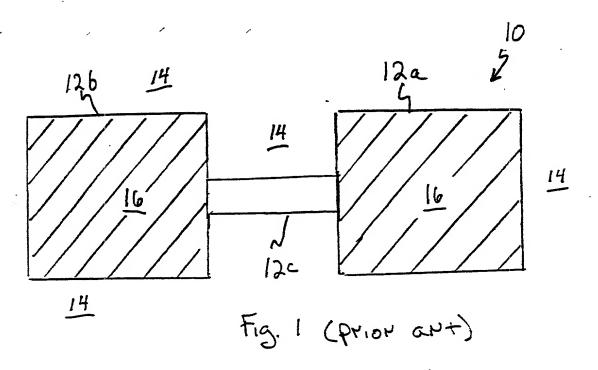
### In Re: Patent Application of Maskawa et al.; Entitled: Single Crystal TFT from Continuous Transition Metal Delivery Method; Attorney Docket Number 318; Sheet 1 of 10



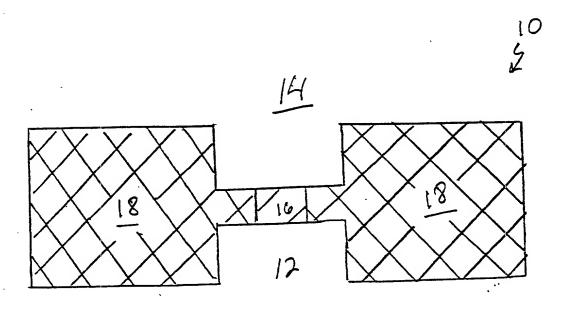
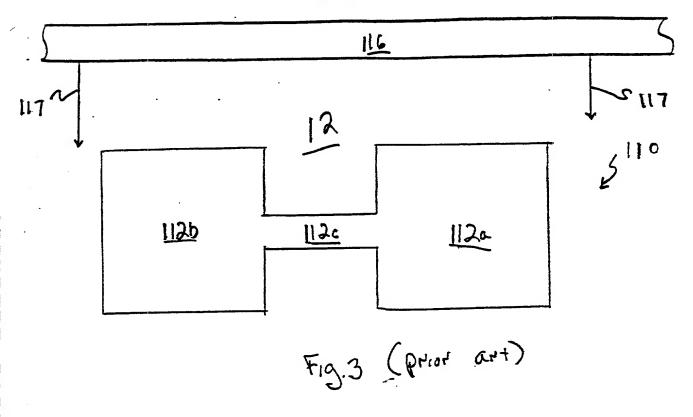


Fig. 2 (prior art)

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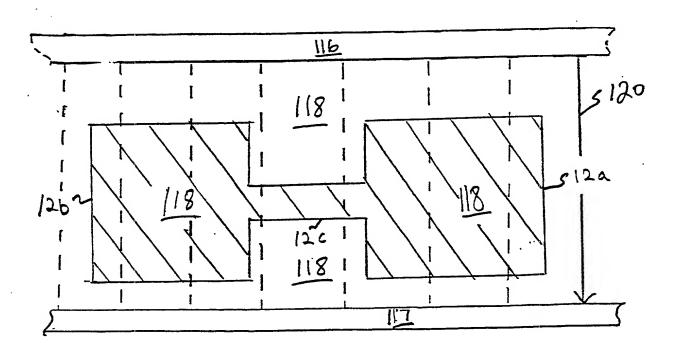
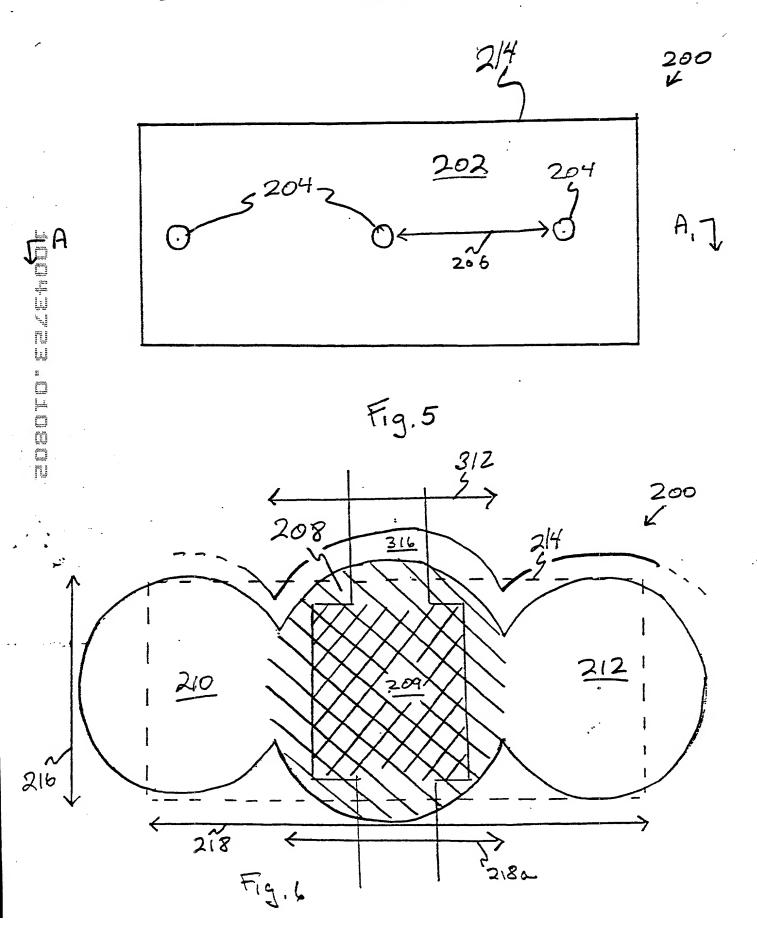
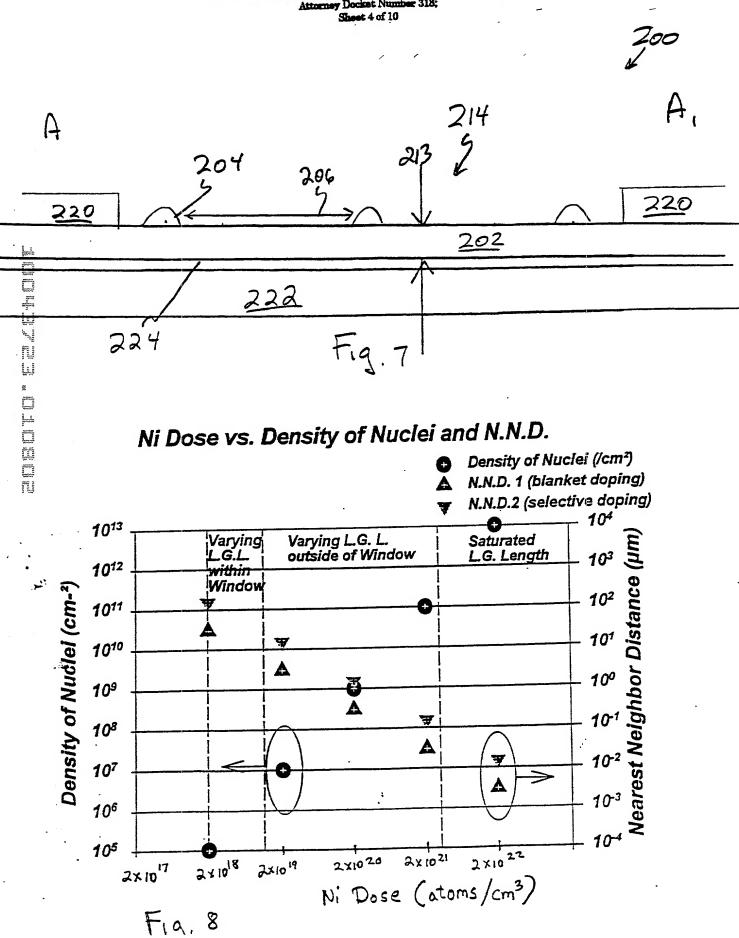


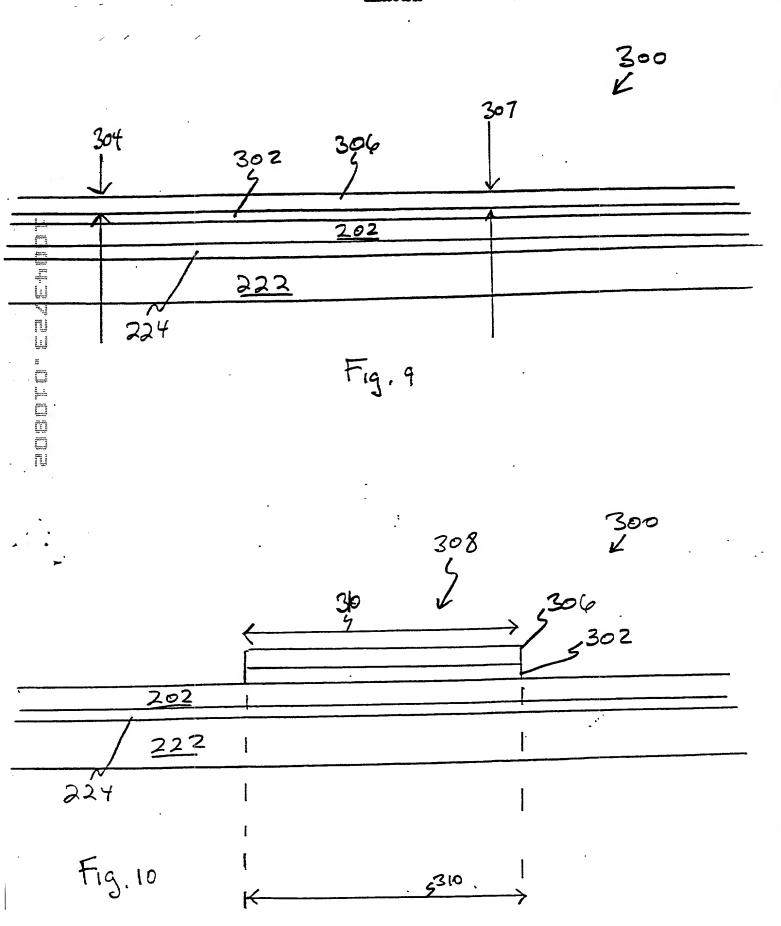
Fig. 4 (prior art)



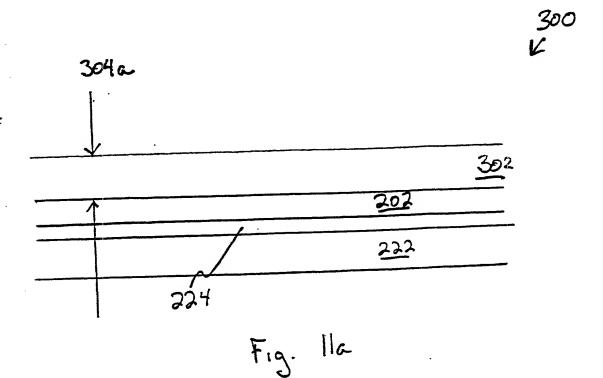
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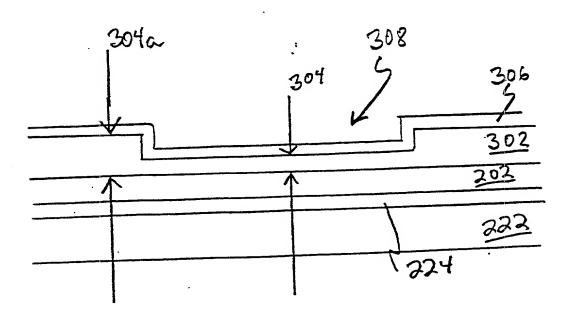
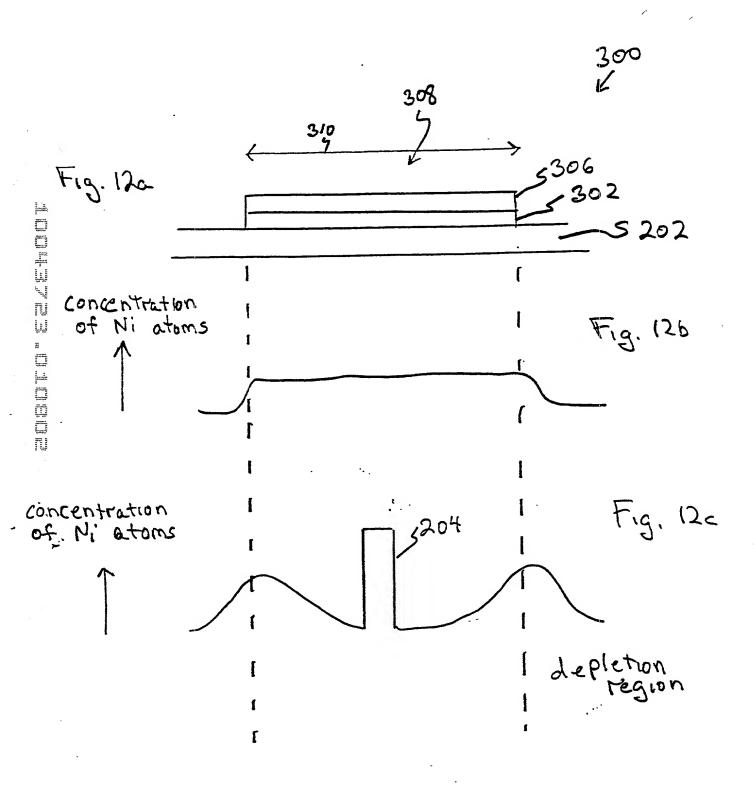
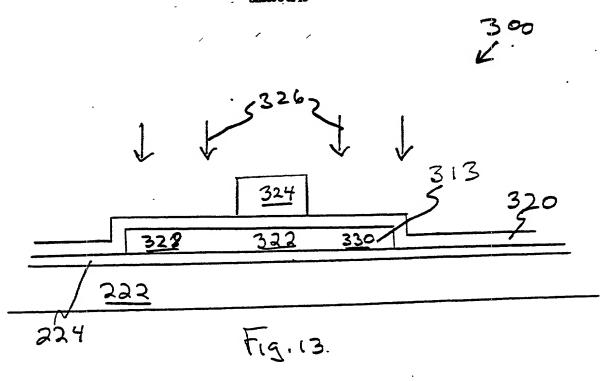
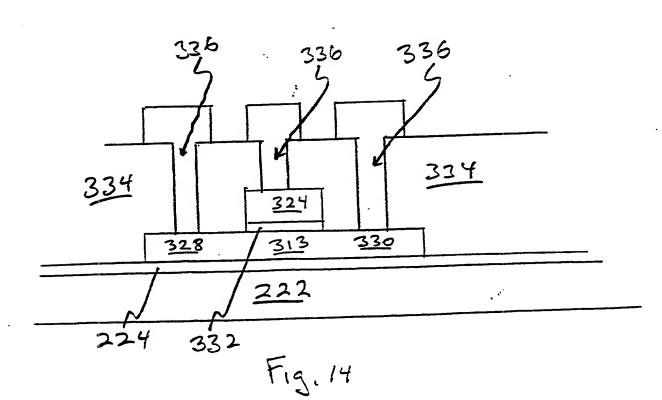


Fig. 11b



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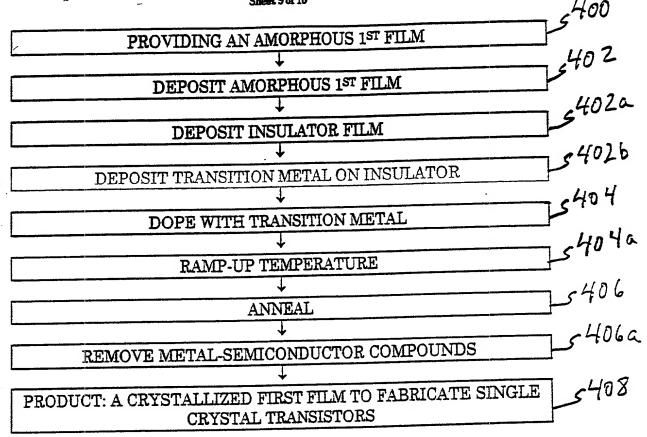


Fig. 15

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THE ANGUNION METAT	5500
PROVIDING SEMICONDUCTOR FILM AND TRANSITION METAL	_
	5502
HEAT BETWEEN 700 AND 750 DEGREES C	
<b>↓</b>	£504
HEAT FOR 1-5 MINUTES	
· · · · · · · · · · · · · · · · · · ·	5506
SUPPLY TRANSITION METAL CONCENTRATION	
<b>+</b>	508
MAINTAIN NUCLEATION SITE DENSITY	
<b>\</b>	510
MAINTAIN NUCLEATION SITE DISTANCE	
<b>+</b>	
PRODUCT: LARGE CRYSTAL GRAINS CORRESPONDING TO	5512
DISTANCE BETWEEN NUCLEATION SITES	

Fig. 16